

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant : | Shunpei Yamazaki et al. | Art Unit : | 2673 |
| Serial No. : | 09/504,235 | Examiner : | David L. Lewis |
| Filed : | February 15, 2000 | Confirmation No.: | 7610 |
| Title : | METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE | | |

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form. Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed before the receipt of a first Office Action on the merits after the filing of a RCE. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 5/19/06


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Substitute Form PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark OfficeAttorney's Docket No.
07977-008004Application No.
09/504,235**Information Disclosure Statement
by Applicant**

(Use several sheets if necessary)

Applicant
Shunpei Yamazaki et al.Filing Date
February 15, 2000Group Art Unit
2673

(37 CFR §1.98(b))

U.S. Patent Documents

| Examiner Initial | Desig. ID | Document Number | Publication Date | Patentee | Class | Subclass | Filing Date If Appropriate |
|------------------|-----------|-----------------|------------------|----------|-------|----------|----------------------------|
| | AA | | | | | | |
| | AB | | | | | | |
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Foreign Patent Documents or Published Foreign Patent Applications

| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Sub-class | Translation | |
|------------------|-----------|-----------------|------------------|--------------------------|-------|-----------|-------------|----|
| | | | | | | | Yes | No |
| | AL | JP06-504139 | 12 MAY 1994 | JAPAN | | | Abstract | |
| | AM | | | | | | | |
| | AN | | | | | | | |
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| | AP | | | | | | | |

Other Documents (include Author, Title, Date, and Place of Publication)

| Examiner Initial | Desig. ID | Document |
|------------------|-----------|--|
| | AQ | Sumiyoshi et al., "DEVICE LAYER TRANSFERRED POLY-SI TFT ARRAY FOR HIGH RESOLUTION LIQUID CRYSTAL PROJECTOR", International Electron Devices Meeting, December 3-6, 1989, IEDM 89, pp. 165-168. |
| | AR | |
| | AS | |
| | AT | |

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.